CERTIFICATE OF TRANSMISSION

I hereby certify that this Paper and/or fee is being electronically filed via EFS in the U.S. Patent Office. Commissioner of Patents on August 27, 2008.

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S)

Rajasingh Israel, et al.

TITLE

OPTIMAL SILICON DIOXIDE PROTECTION

LAYER THICKNESS FOR SILVER LAMP

REFLECTOR

APPLICATION NO.

10/633,085

FILED

August 1, 2003

CONFIRMATION NO.

3209

EXAMINER

Anne M. Hines

ART UNIT

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May 28, 2008

ATTORNEY DOCKET NO.:

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GECZ 2 00083-2-3

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT B

Dear Sir:

Responsive to the Non-Final Office Action mailed May 28, 2008, on the above-referenced patent application, Applicants respectfully request reconsideration of the application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.